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Michelle J. Burke
Reg. No. 37,791

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Jerald P. Dykstra

Serial Number: 09/905,536

Filed: July 13, 2001

For: GAS CLUSTER ION BEAM SIZE DIAGNOSTICS AND WORKPIECE PROCESSING

Examiner: N/A

Group Art Unit: 2881

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To: Commissioner for Patents
Washington D.C. 20231-0001

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INFORMATION DISCLOSURE STATEMENT

Sir:

This Information Disclosure Statement (Form PTO-1449) (including copies of references) is submitted under 37 CFR 1.97(b)(3).

REMARKS

Applicant submits herewith an Information Disclosure Statement under 37 CFR 1.97(b)(3) before the mailing of a first office action on the merits. In view thereof, no fee is required, however, in the event fees are required please charge any underpayment of fees to or credit any overpayment of fees to Deposit Account No. 03-2410, Order No. 11460-111.

The following information is presented in the event that a call may be deemed desirable by the Examiner:

MICHELLE J. BURKE (617) 854-4000.

Respectfully submitted,
Jerald P. Dykstra, Applicant

Dated: 1/10/2002

By: *Michelle J. Burke*
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